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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
09/546,174	04/11/2000	1711	1158	JIA 462C1	4	20	3

RECEIVED

bmc-96-279 CON

CONFIRMATION NO. 4793

25235  
HOGAN & HARTSON LLP  
ONE TABOR CENTER, SUITE 1500  
1200 SEVENTEENTH ST  
DENVER, CO 80202

NOV - 3 2004

HOGAN & HARTSON, LLP

CORRECTED FILING RECEIPT



\*OC000000014256854\*

Date Mailed: 11/01/2004

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**Applicant(s)**

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**Domestic Priority data as claimed by applicant**

This application is a CON of 08/958,460 10/28/1997 PAT 6,117,345  
which claims benefit of 60/041,790 04/02/1997

**Foreign Applications**

If Required, Foreign Filing License Granted: 06/15/2000

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US09/546,174**

Projected Publication Date: None, application is not eligible for pre-grant publication

Non-Publication Request: No

Early Publication Request: No



Title

HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS

Preliminary Class

216

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DATE: 10/1/04

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NUMBER OF PAGES INCLUDING THIS PAGE 2

If you have not received all pages of this transmission, please contact this Examining Group as soon as possible at the above telephone number.

Here is the letter that was received in parent application 08/958,460 setting forth the full names of the inventors.

*Rabon Sargent*  
RABON SERGENT  
PRIMARY EXAMINER

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002-1-202-659-1898

July 7, 2000

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U.S.A.

Acknowledged with thanks,  
Rabin & Champagne, P.C.by Lee date 7/10/00

Re: U.S. Patent Application No. 08/958,460

Your Ref:

JIA 462/SMR

Our Ref:

1468-US-PA

703/308 6642

Dear Mr. Rabin:

Thank you for your e-mail of July 7, 2000. Please be advised that the full names of the inventors W.B. Shieh and J.Y. Wu are respectively Wen-Bin Shieh and Juan-Yuan Wu. Please provide the PTO with this information as soon as possible.

Thank you very much for your kind assistance with this matter. Again, please fax us the Issue Notification as soon as you have received it.

Yours faithfully,

JIANQ CHYUN  
INTELLECTUAL PROPERTY OFFICE  
Wilson H. Lee

WILL/s